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PATENT ASSIGNMENT

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SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT

CONVEYING PARTY DATA

Name	Execution Date
Hideto KATO	07/04/2012
Michihiro SUGO	07/04/2012
Shohei TAGAMI	07/04/2012

RECEIVING PARTY DATA

Name:	Shin-Etsu Chemical Co., Ltd.	
Street Address:	6-1, Ohtemachi 2-chome, Chiyoda-ku	
City:	Tokyo	
State/Country:	JAPAN	

PROPERTY NUMBERS Total: 1

Property Type	Number
Application Number:	13556655

CORRESPONDENCE DATA

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NAME OF SUBMITTER: Crystal Boyer

Total Attachments: 1

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PATENT

REEL: 028625 FRAME: 0365

U.S. ASSIGNMENT

FOR GOOD AND VALUABLE CONSIDERATION, the adequacy and receipt of which is hereby acknowledged by the undersigned inventor(s) (hereinafter ASSIGNOR) by

(Insert ASSIGNEE's Name(s) Address(es))

Shin-Etsu Chemical Co., Ltd. of 6-1, Ohtemachi 2-chome, Chiyoda-ku, Tokyo, Japan

(hereinafter ASSIGNEE), the undersigned ASSIGNOR hereby sells, assigns and transfers to ASSIGNEE the entire and exclusive right, title and interest to the invention entitled

(Title of Invention)

(Signatures)

	NATE, WAFER PROCESSING I T, AND THIN WAFER MANUF			
for which application for Letters F unless otherwise indicated below:	ratent of the United States was exc	ecuted on even date herewith		
filed on	Application No			
(Westerman, Hattori, Daniels & Adrian, LLP is hereby authorized to insert the series code, serial number and/or filing date hereon, when known)				
and all Letters Patent of the Unit continuation, divisional, substitute, which the same may be granted.				
The ASSIGNOR agrees to execute all papers necessary in connection with the application and any continuation, divisional, reissue or reexamination applications thereof and also to execute separate assignments in connection with such applications as the ASSIGNEE may deem necessary or expedient.				
The ASSIGNOR agrees to execulitigation, or other legal proceeding continuation, divisional, reissue or thereon and to cooperate with the evidence and proceeding with such	ng which may be declared concer reexamination thereof or Letters F ASSIGNEE in every way possible	rning this application or any latent or reissue patent issued e in obtaining and producing		
IN WITNESS WHEREOF, the und	ersigned inventor(s) has (have) affin	xed his/her/their signature(s).		
Aideto Lato (Signature)	Hideto KATO	July 4, 2012		
(Signature)	(Type Name)	(Date)		
Amo lya	Michihiro SUGO	July 4, 2012		
(Signature)	(Type Name)	(Date)		
Shohei Ingami	Shohei TAGAMI	July 4, 2012		
(Signature)	(Type Name)	(Date)		
(Signature)	(Type Name)	(Date)		
(Signature)	(Type Name)	(Date)		

(Type Name)

NO LEGALIZATION REQUIRED

PATENT REEL: 028625 FRAME: 0366

(Date)

RECORDED: 07/24/2012

(Signature)